

Docket No.: MICRON.106C1

Customer No.: 20,995



Applicant : Li et al.
App. No. : 10/027,519
Filed : December 20, 2001
For : CHEMICAL TREATMENT OF
SEMICONDUCTOR
SUBSTRATES
Examiner : Victor V. Yevsikov
Art Unit : 2825

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

November 15, 2004

(Date)

Tina Chen, Reg. No. 44,606


Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Certificate
NOV 23 2004
of Correction

Sir:

Transmitted herewith for filing in the above-identified application are the following enclosures:

- (X) Certificate of Correction
- (X) Return prepaid postcard.


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UNITED STATES PATENT AND TRADEMARK OFFICE CERTIFICATE OF CORRECTION

PATENT NO. : 6,774,058 B2

DATED : August 10, 2004

INVENTOR(S): Li et al.

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

The patent needs to correctly list both inventors, as stated on the attached declaration. The correct inventors are as listed:

Li Li and Weimin Li

Currently, the patent incorrectly lists Li Li as the sole inventor.

MAILING ADDRESS OF SENDER:

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November 15, 2004

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